semiconductors to absorb photons by conferring that energy to carriers of electrical current and the ability of semiconductor materials to conduct electricity.

The basic operating principles of the solar cell (a carefully designed *pn*-junction diode) were derived from the (simplified) equations describing the dynamics of holes and electrons in semiconductors. This led to the definition of the solar cell figures of merit – the open-circuit voltage (V_{OC}), the short-circuit current (I_{SC}), the fill factor (FF), and the cell efficiency (η). The two key factors determining solar cell efficiency – electron–hole pair generation and recombination – were identified and discussed. In particular, the need to minimize all sources of recombination in the solar cells was demonstrated through examples and by way of a simple analogy.

The importance of matching the band gap of the solar cell material to the solar spectrum was also discussed and it was shown that silicon, with a band gap of 1.12 eV, is an excellent match to the solar spectrum. The effects of parasitic resistances and temperature on solar cell performance were examined and, finally, some advanced cell concepts were briefly introduced. Many of these topics will be expanded upon in the following chapters of this handbook.

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